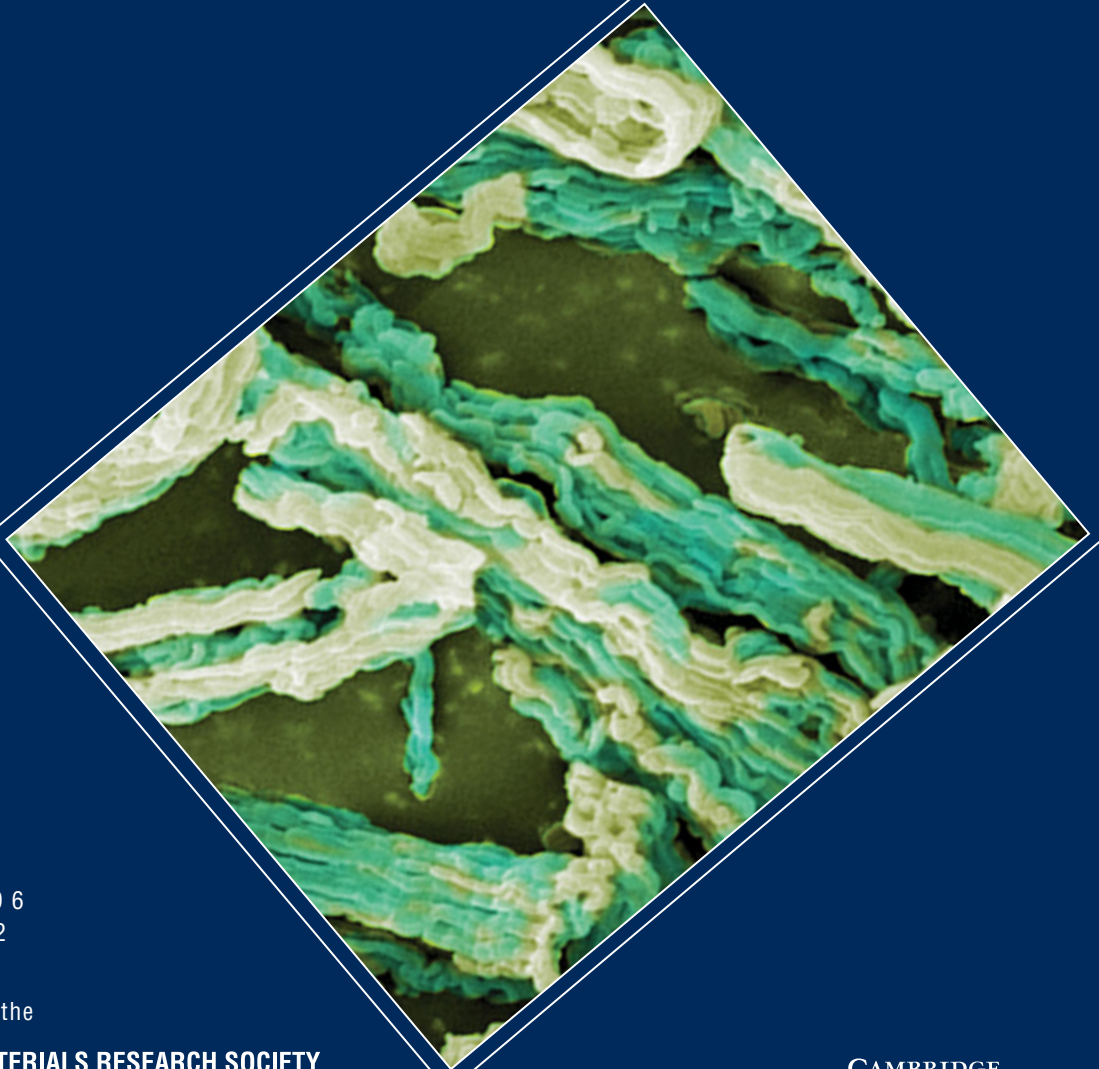




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Journal of MATERIALS RESEARCH

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Cover: Scanning electron microscopy image of SBA-15. [Y. Khaniani, A. Badiei, and G. Mohammadi Ziarani: Application of clickable nanoporous silica surface for immobilization of ionic liquids. p. 932.]

Journal of MATERIALS RESEARCH

Volume 27, Number 6, March 28, 2012

INVITED FEATURE PAPERS

Review

- 869–878 **Observation of filament formation process of Cu/HfO₂/Pt ReRAM structure by hard x-ray photoelectron spectroscopy under bias operation** Takahiro Nagata, Masamitsu Haemori, Yoshiyuki Yamashita, Hideki Yoshikawa, Keisuke Kobayashi, Toyohiro Chikyow

Articles

- 879–885 **Influence of laser interference patterning on microstructure and friction behavior of gold/yttria-stabilized zirconia nanocomposite thin films** Rodolphe Catrin, Thomas Gries, Brice Raillard, Frank Mücklich, Sylvie Migot, David Horwat
- 886–896 **Analysis of resistance switching and conductive filaments inside Cu-Ge-S using in situ transmission electron microscopy** Takashi Fujii, Masashi Arita, Yasuo Takahashi, Ichiro Fujiwara
- 897–909 **Excitation spectrum of point defects in semiconductors studied by time-dependent density functional theory** Adam Gali

ARTICLES

- 910–914 **Microwave dielectric properties of low loss and highly tunable Ba_{0.5}Sr_{0.5}Ti_{1–3y/2}W_yO₃ ceramics** Mingwei Zhang, Jiwei Zhai, Bo Shen, Xi Yao
- 915–921 **Crystal structure and microwave dielectric properties of low temperature sintered MgO ceramic with LiF addition** Akinori Kan, Hirotaka Ogawa, Tohru Moriyama
- 922–927 **Tunable dielectric properties in Mn-doped LuFe₂O₄ system** Ying Hou, Yiping Yao, Sining Dong, Xi Huang, Xuefeng Sun, Xiaoguang Li
- 928–931 **Effects of Mg substitution on microstructure and electrical properties of NiMn_{2–x}Mg_xO₄ NTC ceramics** Jiangying Wang, Jingji Zhang
- 932–938 **Application of clickable nanoporous silica surface for immobilization of ionic liquids** Yeganeh Khaniani, Alireza Badiei, Ghodsi Mohammadi Ziarani
- 939–943 **Yttria-stabilized zirconia crystallization in Al₂O₃/YSZ multilayers** Nihan Kemik, Sergey V. Ushakov, Meng Gu, Nicole Schichtel, Carsten Korte, Nigel D. Browning, Yayoi Takamura, Alexandra Navrotsky
- 944–950 **Nanoscale structure of Ti_{1–x}Nb_yO₂ mixed-phase thin films: Distribution of crystal phase and dopants** Paul A. DeSario, Jinsong Wu, Michael E. Graham, Kimberly A. Gray
- 951–958 **Standing porous ZnO nanoplate-built hollow microspheres and kinetically controlled dissolution/crystal growth mechanism** Xianbiao Wang, Weiping Cai, Guozhong Wang, Changhao Liang
- 959–964 **Enhancement on afterglow properties of Eu³⁺ by Ti⁴⁺, Mg²⁺ incorporation in CaWO₄ matrix** Haoyi Wu, Yihua Hu, Fengwen Kang, Nana Li

(Continued)

- 965–970 **Activation of plasmons and polarons in solar control cesium tungsten bronze and reduced tungsten oxide nanoparticles**
- 971–977 **Characterization study of GaN-based epitaxial layer and light-emitting diode on nature-patterned sapphire substrate**

Kenji Adachi, Tsuyoshi Asahi

H.Y. Lin, Y.J. Chen, C.L. Chang,
X.F. Li, C.H. Kuo, S.C. Hsu,
C.Y. Liu

ERRATUM

- 978 **Localized recrystallization and cracking of lead-free solder interconnections under thermal cycling – ERRATUM**

Hongtao Chen, Maik Mueller,
Toni Tuomas Mattila, Jue Li,
Xuwen Liu, Klaus-Juergen Wolter,
Mervi Paulasto-Kröckel